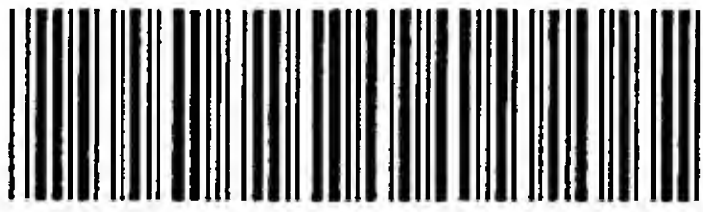


<div>Search Notes</div> <div></div>	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/709,612	YEH, EN-HSIANG	
	Examiner	Art Unit	
	Krista M. Flanagan	2817	

SEARCHED			
Class	Subclass	Date	Examiner
330	124R	10/20/2005	KMF
330	295	10/20/2005	KMF

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Inventorship	9/29/2005	KMF
EAST - 330/295 and (low\$3 reduce\$2) adj2 impedance (adj4 (output out)) and cascode	10/14/2005	KMF
330/98-100 and 311 and cascode	10/27/2005	KMF